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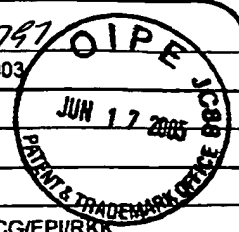
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 1

of 2

Application Number	10/688,420-797
Filing Date	October 17, 2003
First Named Inventor	Singh, et al.
Group Art Unit	1762
Examiner Name	Unknown
Attorney Docket Number	AMAT/7729/TCG/EPI/RK
Submission Date	June 17, 2005



U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
	A1	US-6821825 B2	11/23/2004	Todd	
	A2	US-6797558 B2	09/28/2004	Nuttall, et al.	
	A3	US-6562720 B2	05/13/2003	Thiderkvist, et al.	
	A4	US-6489241 B1	12/03/2002	Thiderkvist, et al.	
	A5	US-6451119 B2	09/17/2002	Sneh, et al.	
	A6	US-6335280 B1	01/01/2002	van der Jeugd	
	A7	US-6291319 B1	09/18/2001	Yu, et al.	
	A8	US-6159852	12/12/2000	Nuttall, et al.	
	A9	US-6042654	03/28/2000	Comila, et al.	
	A10	US-5906680	05/25/1999	Meyerson	
	A11	US-5273930	12/28/1993	Steele, et al.	
	A12	US-5112439	05/12/1992	Reisman, et al.	
	A13	US-20050079691 A1	04/14/2005	Kim, et al.	
	A14	US-20040253776 A1	12/16/2004	Hoffmann, et al.	
	A15	US-20040226911 A1	11/18/2004	Dutton, et al.	
	A16	US-20040033674 A1	02/19/2004	Todd	
	A17	US-20030189208 A1	10/09/2003	Law, et al.	
	A18	US-20020197831 A1	12/26/2002	Todd, et al.	
	A19	US-20020145168 A1	10/10/2002	Bojarczuk, Jr., et al.	
	A20	US-20020090818 A1	07/11/2002	Thiderkvist, et al.	

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
	C1	Kamins, et al. "Kinetics of selective epitaxial deposition of Si ₃ Ge ₂ ", Applied Physics Letters, American Institute of Physics. New York, US, vol. 61, no. 6, 10 August 1992, pp. 669-671	
	C2	Menon, et al. "Loading effect in SiGe layers grown by dichlorosilane- and silane-based epitaxy", Journal of Applied Physics, American Institute of Physics. New York, US, vol. 90, no. 9, 1 November 2001, pp. 4805-4809	

Examiner

Date Considered

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